

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	CHEMICAL MECHANICAL POLISHING PROCESS
--------------------	---------------------------------------

Application Number : 10/711392

Confirmation Number:

First Named Applicant: Chia-Lin Hsu

Attorney Docket Number: NAUP0633USA

Art Unit: 3723

Examiner: Jacob Aclen

Search string: ( 6573173 ).pn

## US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
J.A.	1	6573173	2003-06-03	Farkas, ET AL.	—	—	

## Signature

Examiner Name	Date
Jacob Aclen JR.	4/8/05